



*IFW*  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KARSTEN WIECZOREK  
MANFRED HORSTMANN  
ROLF STEPHAN

Examiner: Thanh T. Nguyen

Group Art Unit: 2813

Serial No.: 10/624,776

Att'y Docket: 2000.104300/DE0116

Filed: July 22, 2003

Customer No.: 23720

For: METHOD OF REMOVING FEATURES  
USING AN IMPROVED REMOVAL  
PROCESS IN THE FABRICATION OF A  
SEMICONDUCTOR DEVICE

**RESPONSE TO RESTRICTION REQUIREMENT  
DATED OCTOBER 19, 2004; PRELIMINARY AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING  
37 C.F.R. 1.8

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below:

November 15, 2004  
Date

*Mary Paul*  
Signature

This paper is submitted in response to the Restriction Requirement dated October 19, 2004, for which the one-month date for response is November 19, 2004.

A fee in the amount of \$320.00 is believed to be due in connection with the present paper. **The Director is authorized to deduct such fee, and any other fees required under 37 C.F.R. §§ 1.16 to 1.21, from the Advanced Micro Devices, Inc. Deposit Account No. 01-0365/DE0116.** In the event the monies in that account are insufficient, the Director is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.104300.

11/19/2004 AWONDAF1 00000072 010365 10624776

01 FC:1201 176.00 DA  
02 FC:1202 144.00 DA